



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#16/10410

Date July 1, 2003

In re the Application of

Yasushi YAMAZAKI et al.

Group Art Unit: 2811

Application No.: 09/970,766

Examiner: S. Hu

Filed: October 5, 2001

Docket No.: 110791

For: METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE, SEMICONDUCTOR SUBSTRATE, ELECTRO-OPTICAL APPARATUS AND ELECTRONIC EQUIPMENT

Admit

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 11, 2003, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 143720 in the amount of \$110.00 in payment for:

- ☒ Extension fee for response within first month pursuant to §1.136(a) (\$110.00)  
☐ Extension fee for response within second month pursuant to §1.136(a) (\$410.00)  
☐ Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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JAO:JML/vgp

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**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461

